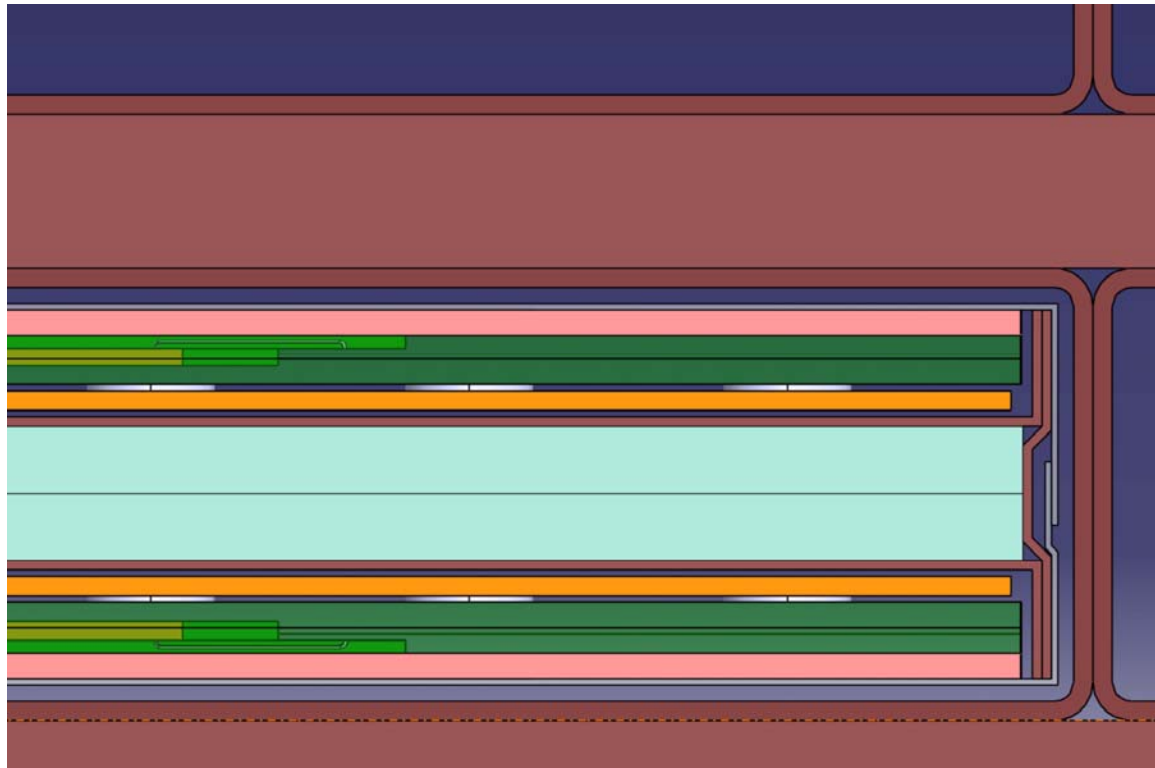


Detector SLAB Integration EUDET Prototype

- Slab cross section, thickness budget
- Space Frame Ladder {Step I assembly}
- Flip Soft Ladder {A.S.U up side down tilt}
- Main Integration Cradle
- Thermal & Integration Training Mockup

SLAB cross section/ thickness budget



- ⇒ Outer envelop (housing) : 100 μm
{omega shape clamped to H+W stave}
- ⇒ Heat shield (Cu) : 400 μm
- ⇒ Electrical non-conductor foam : 150 μm
{Thermal diffuser & conductor material}

- ⇒ PCB : 800 μm (tolerances : \pm ?)
but chips embedded in PCB ?
- ⇒ Thickness of glue : <100 μm ?
study of the size of dots
- ⇒ Thickness of wafer : 320 μm
- ⇒ Kapton® film HV feeding :
100 μm - OK (*DC coupling*)

- ⇒ Thickness of W : 2100 μm (\pm 80 μm)

Space Frame Ladder

A.S.U interconnection & HV feeding

- ⇒ Std Aluminum structure : free access to A.S.U interconnection, HV feeding & DIF + Terminal boards.
1. HV kapton clamping to the space frame ladder
 2. unit-1 A.S.U insertion into the ladder & HV connection *{disconnection process to be studied}*
 3. unit-2 A.S.U insertion, into the ladder & HV connection
 4. unit-1 to unit-2 interconnection *{kapton bridge technique could answer major specifications}*
 5. Electrical qualification & unit-3, unit-4, etc... insertion
 6. Full electrical qualification after DIF + Terminal boards integration

Flip Soft Ladder full sensitive SLAB handling

- ⇒ Std Aluminum structure : adequate 'soft rubber' edges as direct contact with sensitive SLAB components
1. Mechanical connection of the flip soft ladder to the space frame ladder *{all sensitive parts are 'sandwich' maintained in-between}*
 2. Clamping of the sensitive parts to the flip soft ladder
 3. Removal of the space frame ladder *{full access to HV kapton feeding}*
 4. Sensitive SLAB + soft ladder clamping to integration cradle *{to be operated 'under' the cradle, H+W structure already installed}*
 5. 180° up side down tilt of the assembly and soft ladder removal *{HV kapton feeding & sensitive SLAB safely clamped to the cradle}*

Main Integration Cradle

H+W structure, sensitive SLAB & Thermal shielding

- ⇒ Std Aluminum structure : fully adapted to the H+W structure which is the direct support of sensitive SLAB & thermal shielding
1. Lateral & 'opposite' clamping of the H+W structure to the main cradle
{sensitive slab + soft ladder free access to H+W structure}
 2. After soft ladder removal, summary electrical checking of all sensitive parts
{A.S.U + HV feeding + DIF + terminal boards}
 3. Electrical insulator foam application *{no glue required}*
 4. Copper shielding insertion *{possible thermal grease but no glue required}*
 5. Cu full clamping to H+W structure with omega shape housing *{H+W lateral grooves are used to clamp Ω envelope}*

Thermal & Integration training Mockup

mechanical handling & thermal measurements

⇒ Heat dissipation 14.4mW/PCB : PCB (100-80 μm), kapton heaters, T°C sensors, data controller, etc...

1. One PCB, 8 kapton heaters, 8 T°C sensors (strain gages) *{thermal setup in progress at LAL-Orsay}*
2. Cupper shielding, electrical insulator foam & Ω shape housing will be added to complete the setup
3. LPSC cooling device & alveolar structure could be integrated to the this thermal setup *{real state confinement at LAL, LPSC or LLR}*